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PATENT
Customer No. 22,852
Attorney Docket No. 4329.2821-01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Riichiro TAKAHASHI et al.)
)
Application No.: 10/824,482)
)
Filed: April 15, 2004)
)
For: ALKALINE SOLUTION AND)
MANUFACTURING METHOD, AND)
ALKALINE SOLUTION APPLIED TO)
PATTERN FORMING METHOD, RESIST) Group Art Unit: 1752
FILM REMOVING METHOD, SOLUTION)
APPLICATION METHOD, SUBSTRATE) Examiner: Not yet assigned.
TREATMENT METHOD, SOLUTION)
SUPPLY METHOD, AND)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(b), Applicants bring to the attention of the Examiner the documents on the attached IDS Form PTO/SB/08. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits for the above-referenced application.

Copies of the listed foreign document and an Office Action dated December 10, 2004, issued by Chinese Patent Office, citing the listed document are attached.

The relevance of Japanese patent publication no. 6-95396 is discussed in the Chinese Office Action, an English translation of which is attached.

Applicants respectfully request that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached IDS form.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and Applicants determine that the cited documents do not constitute "prior art" under United States law, Applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

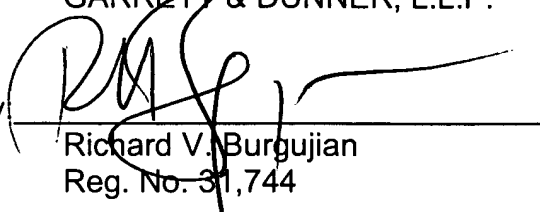
If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

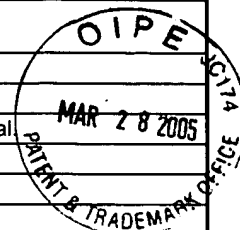
FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: March 28, 2005

By


Richard V. Burgujian
Reg. No. 31,744

IDS Form PTO/SB/08: Substitute for form 1449A/PTO			Complete if Known		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/824,482	
			Filing Date	April 15, 2004	
			First Named Inventor	Riichiro TAKAHASHI et al.	
			Art Unit	Not yet assigned	
			Examiner Name	Not yet assigned	
Sheet	1	of	1	Attorney Docket Number	04329.2821-01



U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-			
		US-			
		US-			
		US-			
		US-			

Note: Submission of copies of U.S. Patents and published U.S. Patent Applications is not required.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	Translation ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
	1	JP 6-95396	04/08/1994			

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Translation ⁶
	2	Office Action dated December 10, 2004, issued by Chinese Patent Office in Chinese Patent application no. 02119275.8	Yes

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.